## SHORT COMMUNICATION Size Effects in the Thermal Variations of the Hall Coefficient

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A number of experimental investigations of the temperature T dependence of the Hall coefficient  $R_{HF}$  of thin metallic films have been reported<sup>1-9</sup> in the past few years. However some data have only been interpreted in terms of the temperature dependence of the electron density  $\eta^{7,8,9}$ , even if the transport properties of these metallic films agree<sup>3,6,7,9,10</sup> with the well known Fuchs–Sondheimer theory.<sup>11</sup>

In a previous paper<sup>12</sup> we have derived an expression for the correction in the temperature coefficient,  $\beta_{RH}$  of the Hall coefficient  $R_{HF}$  of thin film arising from the temperature dependence of the bulk mean free path  $l_0$ . Unfortunately in the case of partially specular scattering of electrons on the external surfaces the expression of  $\beta_{RH}$  is somewhat complicated and its numerical evaluation requires the use of a digital computer.

In order to allow an easier calculation this letter proposes an alternative approach to derive an analytical expression for  $\beta_{RH}$ : it is taken into account that for nearly specular scattering on external surfaces the surface scattering can be treated with good approximation by the Cottey method<sup>13</sup> which states that the film resistivity  $\rho_F$  and its temperature coefficient  $\beta_F$  are respectively given by:<sup>13,14</sup>

$$\rho_0 / \rho_F = F(\mu) = \frac{3}{2} \mu \{ \mu - \frac{1}{2} + (1 - \mu^2) \ln(1 + \mu^{-1}) \}$$
(1)

$$\beta_F / \rho_0 = 1 - G(\mu) \cdot [F(\mu)]^{-1}$$
(2)

where:14

$$G(\mu) = \mu \frac{\mathrm{d}F(\mu)}{\mathrm{d}\mu} = \frac{3}{2}\mu \left\{ 3\mu - \frac{3}{2} + (1 - 3\mu^2)\ln(1 + \mu^{-1}) \right\}$$
(3)

Here  $\beta_0$  is the temperature coefficient (t.c.r.) of the bulk resistivity  $\rho_0$  which can be written in the form:<sup>15</sup>

$$\beta_0 = d \ln \rho_0 / dT = -d \ln l_0 / dT \tag{4}$$

The physical parameter  $\mu$  is related to the specularity parameter p and to the reduced thickness k by:<sup>13</sup>

$$\mu = k \cdot \left[ \ln \frac{1}{p} \right]^{-1} \approx k \cdot [1-p]^{-1}; \ p \ge 0.5 \quad (5)$$

with:  $k = a/l_0$ .

We have previously shown<sup>16</sup> that in the case of transverse magnetic field the Hall coefficient of thin metallic  $R_{HF}$  can be expressed in terms of film resistivity  $\rho_F$  and its t.c.r.  $\beta_F$ :

$$R_{HF}/R_{HO} \approx (\rho_F \cdot \beta_F)/(\rho_0 \cdot \beta_0) \tag{6}$$

where  $R_{HO}$  is the Hall coefficient in bulk material. By combining Eqs. (1), (2) and (6) we get:

$$R_{HF}/R_{HO} = [1 - D(\mu)] \cdot [F(\mu)]^{-1}$$
(7)

with: 
$$D(\mu) = G(\mu)/F(\mu)$$
 (8)

Taking into account the value of the bulk Hall coefficient  $R_{HO}$ :<sup>7,17</sup>

$$R_{HO} = -\frac{1}{\eta e}$$

we get:

$$\frac{\mathrm{d}R_{HO}}{R_{HO}} = -\frac{\mathrm{d}\eta}{\eta} \tag{9}$$

Moreover Eq. (5) yields:

$$\frac{\mathrm{d}\mu}{\mu} = -\frac{\mathrm{d}l_0}{l_0} \tag{10}$$

assuming that thermal variations in thickness a and specularity parameter can be neglected; the validity of these assumptions has been recently established.<sup>18</sup>

Logarithmic differentiation of Eq. (7) leads to:



FIGURE 1 Theoretical plots of the ratio  $(\beta_{RH} + \beta_{\eta})/\beta_0$  versus the reduced thickness k for some values of the specularity parameter p.

$$\frac{\mathrm{d}R_{HF}}{R_{HF}} = -\frac{\mathrm{d}\eta}{\eta} + \frac{\mathrm{d}l_0}{l_0} \frac{D(\mu)}{1 - D(\mu)} \left\{ \frac{\mu}{G(\mu)} \frac{\mathrm{d}G(\mu)}{\mathrm{d}\mu} - \frac{\mu}{F(\mu)} \frac{\mathrm{d}F(\mu)}{\mathrm{d}\mu} \right\} + \frac{\mathrm{d}l_0}{l_0} \left\{ \frac{\mu}{F(\mu)} \cdot \frac{\mathrm{d}F(\mu)}{\mathrm{d}\mu} \right\}$$
(11)

For thin films which exhibit linear  $R_{HF}$  versus T plots as previously reported by some authors<sup>7</sup> we may define the temperature coefficient  $\beta_{RH}$  of Hall coefficients as:

$$\beta_{RH} = \mathrm{d} \ln R_{HF} / \mathrm{d}T \tag{12}$$

by combining Eqs. (3), (4) and (11) and rearranging we finally obtain:

$$\beta_{RH} = -\beta_{\eta} - \beta_0 \cdot D(\mu) \left\{ \frac{C(\mu) - D(\mu)}{1 - D(\mu)} + 1 \right\}$$
(13)

where:

$$C(\mu) = \frac{\mu}{G(\mu)} \cdot \frac{\mathrm{d}G(\mu)}{\mathrm{d}\mu} \tag{14}$$

and:

$$\mu \frac{\mathrm{d}G(\mu)}{\mathrm{d}\mu} = \frac{3}{2} \mu \left\{ G(\mu) - \frac{3}{2} + (1 - 9\mu^2) \ln(1 + \mu^{-1}) - \frac{1 - 3\mu^2}{1 + \mu} \right\}$$
(15)

 $\beta_{\eta}$  is the temperature coefficient of the electronic density  $\eta$  previously defined as:<sup>12</sup>

$$\beta_{\eta} = \mathrm{d} \ln \eta / \mathrm{d}T \tag{16}$$

Eq. (13) predicts that  $\beta_{RH}$  depends on the reduced thickness k; this behaviour can be easily explained since it has been found that  $R_{HF}$  markedly depends on film thickness<sup>15,17</sup> for relatively thin films  $(k \le 0.5)$ .

Figure 1 shows theoretical plots of the ratio  $(\beta_{RH} + \beta_{\eta})/\beta_0$  for different values of the specularity parameter *p*. It is clear from Eq. (13) that  $\beta_{RH} + \beta_{\eta}$  gives the expression of the change in temperature of the Hall coefficient due to the temperature dependence of the reduced thickness; hence, as

expected, the ratio  $|(\beta_{RH} + \beta_{\eta})/\beta_0|$  decreases (for a given thickness) with increasing values of the specularity parameter p; moreover it appears that the magnitude of  $(\beta_{RH} + \beta_{\eta})/\beta_0$  rapidly decreases with increasing values of k and finally vanishes for thick films (for example when p = 0.75 for k > 0.1).

More generally marked size effects could be observed only if the magnitude of  $\beta_{\eta}$  is considerably smaller than the generally positive  $\beta_0$  value. For example for p = 0.5 and k = 0.5 we obtain a deviation less than 20% until the ratio  $|\beta_{\eta}/\beta_0|$  keeps values greater than 0.2.

As a consequence of this study we estimate, as suggested in a previous paper,<sup>12</sup> that the temperature dependence of the Hall coefficient of thin metallic films may be (in the relatively high temperature range (T > 150 K)) interpreted in terms of thermal variations in both the electronic density  $\eta(T)$  and the mean free path  $\rho_0(T)$ ; nevertheless, this last effect is significant only if the magnitude of  $\beta_{\eta}$  is considerably less than  $\beta_0$ .

Further insight is thus given for the interpretation of thermal variations in Hall coefficient of thin metallic films.

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